

DO NOT ENTER: /JRD/
10/10/2007

Docket No.: 123056-05004443

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :
:
Sun Jin YUN et al. : Confirmation No. 4540
:
U.S. Patent Application No. 10/777,102 : Group Art Unit: 2815
:
Filed: February 13, 2004 : Examiner: DIAZ, JOSE R

For: SUBSTRATE WITH MICROSTRUCTURE FORMED THEREON AND
MANUFACTURING METHOD THEREOF

AMENDMENT

MAIL STOP AF
COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria VA 22313-1450

Sir:

In response to the Office Action of July 3, 2007 marked final, please amend the
above-identified application and enter the following remarks, as follows:

- **Amendments to the Claims** as reflected in the listing of claims; and
- **Remarks.**